



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 3, 2025

IGI Report Number

LG735579231

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED EMERALD CUT

Measurements

7.97 X 5.35 X 3.61 MM

GRADING RESULTS

Carat Weight

1.54 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

IGI LG735579231
100 FACETS

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG735579231
Report verification at igi.org

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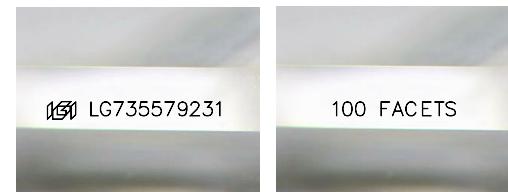
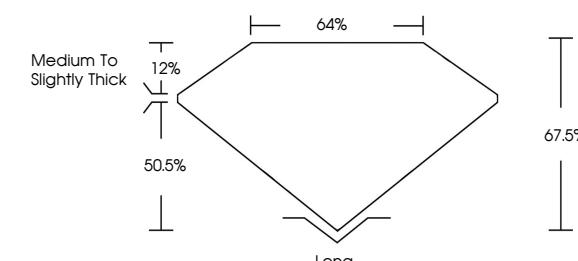
Color Grade

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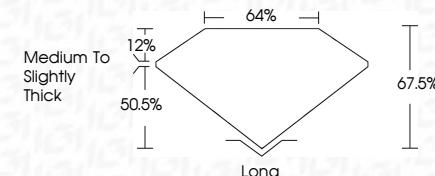
Clarity Grade

VS 1

PROPORTIONS



Sample Images Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS 1-2	VS 1-2	SI 1-2	I 1-3
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

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NONE

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IGI Report No LG735579231
MODIFIED EMERALD CUT
7.97 X 5.35 X 3.61 MM

Carat Weight	1.54 CARAT
Color Grade	E
Clarity Grade	VS 1
Depth	67.5%
Table Grade	64%
Culet	Medium To Slightly Thick
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG735579231 100 FACETS

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